

Electronic Patent Application Fee Transmittal

Application Number:

Filing Date:

Title of Invention:

LOADING DEVICE FOR CHEMICAL MECHANICAL POLISHER OF SEMICONDUCTOR WAFER

First Named Inventor:

Jung Hoon LEE

Filer:

Jeffrey A. Wyand/Malika Ash Shakur

Attorney Docket Number:

403835

Filed as Large Entity

U.S. National Stage under 35 USC 371 Filing Fees

Description

Fee Code

Quantity

Amount

**Sub-Total in
USD(\$)**

Basic Filing:

National Stage Fee

1631

1

300

300

Pages:

Claims:

Miscellaneous-Filing:

Petition:

Patent-Appeals-and-Interference:

Post-Allowance-and-Post-Issuance:

Extension-of-Time:

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Total in USD (\$)				300